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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of

Takayuki SAITO et al.

Serial No. 10/695,826

Filed October 30, 2003

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: **Confirmation No. 7179**

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**Attn: OFFICE OF INITIAL PATENT
EXAMINATION'S FILING RECEIPT
CORRECTIONS**

:

Attorney Docket No. 2003_1585A

SUBSTRATE PROCESSING APPARATUS
AND SUBSTRATE PROCESSING METHOD

REQUEST FOR CORRECTED FILING RECEIPT

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

A corrected filing receipt is requested in the above-referenced case. A copy of the original filing receipt is enclosed, with the changes noted thereon.

Expedited issuance of the corrected filing receipt is respectfully requested.

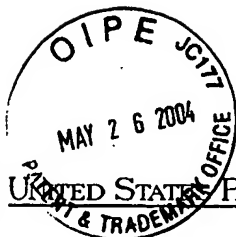
Respectfully submitted,

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APPL NO.	FILING OR 371 (c) DATE	ART UNIT	FIL FEE REC'D	ATTY. DOCKET NO	DRAWINGS	TOT CLMS	IND CLMS
10/695,826	10/30/2003		770	2003_1585A	11	1	1

CONFIRMATION NO. 7179

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 WASHINGTON, DC 20006-1021

FILING RECEIPT



OC000000012445088

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APR 27 2004

WENDEROTH, LIND & PONACK

Date Mailed: 04/26/2004

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Domestic Priority data as claimed by applicant

Foreign Applications

~~JAPAN 2002 211524 07/19/2002~~
~~JAPAN 2002 213078 07/22/2002~~

If Required, Foreign Filing License Granted: 04/23/2004

Projected Publication Date: To Be Determined - pending completion of Missing Parts

Non-Publication Request: No

Early Publication Request: No

Title

Substrate processing apparatus and substrate processing method

Preliminary Class

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Title 35, United States Code, Section 184
Title 37, Code of Federal Regulations, 5.11 & 5.15**

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